

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Norikazu MIZUNO et al.

Serial No: Not assigned

Filed: September 29, 2000

For: SEMICONDUCTOR DEVICE MANUFACTURING METHOD
AND SEMICONDUCTOR MANUFACTURING APPARATUS

Art Unit: Not assigned

Examiner: Not assigned

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- ☒ patent application (19 page(s) of specification; 9 claim(s); 1 page(s) of abstract
- ☒ 6 sheet(s) of formal drawings
- ☒ certified copy of Japanese patent application No. 11-333129 which was filed November 24, 1999 from which priority is claimed in the subject case pursuant to 35 U.S.C. § 119
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